Notice of Allowability	Application No.	Applicant(s)	
	10/821,508	NOZAWA ET AL.	A
	Examiner	Art Unit	
	Steven H VerSteeg	1753	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.			
1. This communication is responsive to <u>response filed November 2, 2004</u> .			
2. \boxtimes The allowed claim(s) is/are <u>6-10 and 12-16</u> .			
3. The drawings filed on <u>09 April 2004</u> are accepted by the Examiner.			
 4. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some* c) None of the: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 09/952,445. 3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements			
noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	••		
5. A SUBSTITUTE OATH OR DECLARATION must be submi INFORMAL PATENT APPLICATION (PTO-152) which give	tted. Note the attached EXAMINER' es reason(s) why the oath or declarate	S AMENDMENT or NOTIC tion is deficient.	CE OF
 6. ☐ CORRECTED DRAWINGS (as "replacement sheets") must (a) ☐ including changes required by the Notice of Draftspers (1) ☐ hereto or 2) ☐ to Paper No./Mail Date (b) ☐ including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.5) 	on's Patent Drawing Review (PTO-S Amendment / Comment or in the O	ffice action of	k) of
each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d). 7. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.			
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	5. ☐ Notice of Informal Pa 6. ☐ Interview Summary (,	2)
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/08	Paper No./Mail Date	e	
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit	<i>_</i>		
of Biological Material	8. ⊠ Examiner's Stateme 9.	nt of Reasons for Allowand	ce

Application/Control Number: 10/821,508

Art Unit: 1753

DETAILED ACTION

EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mark Murphy on November 30, 2004.

The application has been amended as follows:

In the specification:

Page 1, line 1, please insert the following:

--This application is a divisional application of U.S. Patent Application No. 09/952,445 filed September 12, 2001, now U.S. Patent No. 6,783,643--

Allowable Subject Matter

- 2. Claims 6-10 and 12-16 are allowed.
- 3. The following is an examiner's statement of reasons for allowance: it is neither anticipated nor obvious over the prior art of record to have a manufacturing method of a photo mask blank having at least a thin film for forming a pattern on a transparent substrate as claimed by Applicant in claim 6.
- 4. Ohmi discloses a sputtering apparatus used in manufacturing optical articles, not making photomasks. Also, Carcia discloses revolving the substrates, not rotating the substrates on their

Application/Control Number: 10/821,508

Art Unit: 1753

axis. Modifying Ohmi, Carcia, and Mitsui to have rotation about the substrates center axis would require hindsight reasoning.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

General Information

For general status inquiries on applications not having received a first action on the merits, please contact the Technology Center 1700 receptionist at (571) 272-1700.

For inquiries involving Recovery of lost papers & cases, sending out missing papers, resetting shortened statutory periods, or for restarting the shortened statutory period for response, please contact Denis Boyd at (571) 272-0992.

For general inquiries such as fees, hours of operation, and employee location, please contact the Technology Center 1700 receptionist at (571) 272-1300.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Steven H VerSteeg whose telephone number is (571) 272-1348. The examiner can normally be reached on Mon - Thurs (6:30 AM - 5:00 PM).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nam X Nguyen can be reached on (571) 272-1342. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Art Unit: 1753

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Steven H VerSteeg Primary Examiner Art Unit 1753

shv

November 30, 2004